

1st International Workshop on  
**Nano-scale Spectroscopy  
and its Applications to  
Semiconductor Research**

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## Program

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### Sunday, 10 December 2000

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| 18:00 - 20:00 | Welcome reception at the ICTP |
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### Monday, 11 December 2000

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| 8:45 - 9:00  | Opening remarks by the workshop chairman G. Salviati   |
| Session Synchrotron radiation techniques I, chair: Y. Watanabe |  |
| 9:00 - 9:45  | T. Kinoshita, University of Tokyo:<br>WHAT CAN WE DO BY PHOTOELECTRON<br>SPECTROMOCROSCOPY?  |
| 9:45 - 10:10   | S. Di Fonzo, Sincrotrone Trieste:<br>NON-DESTRUCTIVE DETERMINATION OF LOCAL STRAIN UNDER<br>BURIED INTERFACES WITH 100-NANOMETER SPATIAL<br>RESOLUTION |
| 10:10 - 10:35  | K. C. Prince, Sincrotrone Trieste:<br>Surface chemistry of lead sulphide   |
| 10:35 - 11:30 coffee break                                     |  |
| Session Synchrotron radiation techniques II, chair: N. Ueno    |  |
| 11:30 - 11:55  | M. Kiskinova, Sincrotrone Trieste:<br>Scanning Photoemission Microscopy: recent developments and applications  |
| 11:55 - 12:20  | R. J. Phaneuf, University of Maryland:<br>Spatially Resolved Spectra and Energetically Resolved Photoelectron Images                                   |

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|   | of Reactive Surface Phases and PN-Junctions  |
| 12:20 - 12:45   | R. Larciprete, Sincrotrone Trieste:<br>VISIBLE AND UV PULSED LASER PROCESSING OF THE Ti/Si(001) INTERFACE STUDIED BY XPS MICROSCOPY WITH SYNCHROTRON RADIATION |
| 12:45 - 13:10   | E. Di Fabrizio, INFM-TASC:<br>Zone Plate for x-ray applications  |
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| 13:10 - 14:30   | lunch break  |
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| Session Synchrotron radiation techniques III, chair: M. Kiskinova |  |
| 14:30 - 15:15   | N. Ueno, Chiba University:<br>Imaging of organic thin films using electron emission microscope   |
| 15:15 - 15:40   | M. Cinchetti, Johannes Gutenberg Universität Mainz:<br>The Effect of Surface Defects on the Efficiency of GaAsP Photoemitters for Polarised Electron Sources   |
| 15:40 - 16:05   | M. Mynar, DeLong Instruments:<br>X-ray photoemission and low energy electron microscope  |
| 16:05 - 16:30   | B. Kaulich, ESRF:<br>X-RAY MICROSCOPY AND SPECTROMICROSCOPY TECHNIQUES USING MULTI KEV PHOTONS   |
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| 16:30 - 17:00   | coffee break   |
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| Session Synchrotron radiation techniques IV, chair:T. Kinoshita   |  |
| 17:00 - 17:45   | S. Heun, Sincrotrone Trieste:<br>PHOTOELECTRON SPECTROSCOPY FROM INDIVIDUAL HETEROEPITAXIAL NANOCRYSTALS ON GaAs(001)  |
| 17:45 - 18:10   | M. Bertolo, Sincrotrone Trieste:<br>Cross-sectional photoemission microscopy of semiconductor heterostructures   |

**Tuesday, 12 December 2000**

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| Session Synchrotron radiation techniques V, chair: S. Heun |   |
| 9:00 - 9:45  | Y. Watanabe, NTT Basic Research Laboratories:<br>Synchrotron radiation photoelectron spectroscopy of nanostructures                                     |
| 9:45 - 10:10   | A. Barinov, Sincrotrone Trieste:<br>Formation stages and thermal stability of metal/n-GaN interface   |
| 10:10 - 10:35  | C. Teichert, Montanuniversität Leoben:<br>Self-organized semiconductor nanostructures and their applications  |
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| 10:35 - 11:30  | coffee break  |
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| Session Scanning probe techniques I, chair: S. Ushioda     |   |
| 11:30 - 12:15  | R. Cingolani, Universita' di Lecce:<br>Wavefunction mapping in single quantum dots  |
| 12:15 - 12:40  | J. Wiebe, Hamburg University:<br>An Ultra High Vacuum-300 mK-Scanning Tunneling Microscope for Local Measurements of the Density of States on InAs(110) |
| 12:40 - 13:05  | F. Rosei, Università di Roma Tor Vergata:<br>Growth and characterization of Ge/Si(111) quantum dots by Scanning Tunneling Microscopy                    |
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| 13:05 - 15:00  | lunch break   |
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| 15:00 - 18:00  | Excursion to Sincrotrone Trieste  |

**Wednesday, 13 December 2000**

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| Session Scanning probe techniques II, chair: M. Sakurai |  |
| 9:00 - 9:45   | S. Ushioda, Tohoku University:<br>Probing of electronic transitions with atomic scale spatial resolution |
| 9:45 - 10:10  | T. K. Johal, Universita di Lecce:  |

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|  | IMAGING OF QUANTUM DOT STATES BY SCANNING TUNNELING SPECTROSCOPY   |
| 10:10 - 10:35  | K. Kanisawa, NTT Basic Research Laboratories:<br>IMAGING OF ZERO-DIMENSIONAL STATES IN SEMICONDUCTOR NANOSTRUCTURES USING SCANNING TUNNELING MICROSCOPY                            |
| 10:35 - 11:00  | B. Ressel, Sincrotrone Trieste:<br>ELECTRONIC STRUCTURE OF THE Pb/Si(111) MOSAIC PHASE   |
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| 11:00-11:30  | coffee break   |
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| Session Scanning probe techniques III, chair: M. Colocci |  |
| 11:30 - 12:15  | M. Sakurai, RIKEN:<br>STM-INDUCED LIGHT EMISSION FROM NANOSTRUCTURES ON A SI(001)-(2X1)-D SURFACE  |
| 12:15 - 12:40  | L. Ottaviano, INFM Unità dell'Aquila:<br>On the spatially resolved electronic structure of polycrystalline WO <sub>3</sub> films investigated with Scanning Tunneling Spectroscopy |
| 12:40 - 13:05  | J. P. Singh, Nuclear science Centre New Delhi:<br>Electronic excitations induced enhancement in metallicity on HOPG and Si surfaces: in-situ STM/STS studies                       |
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| 13:05 - 14:30  | lunch break  |
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| Session Scanning probe techniques IV, chair: K. Yagi     |  |
| 14:30 - 15:15  | S.-W. Hla, Freie Universität Berlin:<br>Single Molecule Engineering with a Scanning Tunneling Microscope   |
| 15:15 - 15:40  | H. Iwasaki, Osaka University:<br>STM Nanolithography on SiO <sub>2</sub> /Si   |
| 15:40 - 16:05  | N. Jug, Institute Josef Stefan Ljubljana:<br>Surface structure of some transition-metal trichalcogenides   |

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| 16:05 - 16:50   | A. Armigliato, CNR-Istituto LAMEL Bologna:<br>STRAIN ANALYSIS IN SUBMICRON ELECTRON DEVICES BY<br>CONVERGENT BEAM ELECTRON DIFFRACTION   |
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| 16:50 - 17:00   | coffee break   |
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| Session Scanning probe techniques V, chair: S.-W. Hla |  |
| 17:00 - 17:45   | M. Colocci, INFM Firenze:<br>New trends in the optical investigation of semiconductor heterostructures at<br>the nanoscale   |
| 17:45 - 18:10   | A. Crottini, Swiss Federal Institute of Technology Lausanne:<br>A novel tip-surface distance control for low temperature scanning near-field<br>photoluminescence spectroscopy |
| 18:10 - 18:35   | L. Sirigu, Swiss Federal Institute of Technology-EPFL Lausanne:<br>OPTICAL PROPERTIES OF V-GROOVE QUANTUM WIRE LASERS<br>AND LED   |
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| 20:00 - 23:00   | Social dinner  |

**Thursday, 14 December 2000**

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| Session Electron microscopy techniques I, chair: G. Salviati |  |
| 9:00 - 9:45  | N. Yamamoto, Tokyo Institute of Technology:<br>TEM-Cathodoluminescence Study of Microstructures and Defects in<br>Semiconductor Epilayers  |
| 9:45 - 10:10   | M. Ivanda, Rudjer Boskovic Institute Zagreb:<br>COMPARISON OF HIGH RESOLUTION TRANSMISSION ELECTRON<br>MICROSCOPY AND LOW FREQUENCY RAMAN SCATTERING IN<br>DETERMINATION OF PARTICLES SIZE DISTRIBUTION OF<br>NANOSIZED TiO <sub>2</sub> |
| 10:10 - 10:35  | A. Patnaik, Indian Institute of Technology Madras:<br>STRUCTURE AND CHARGE TRANSPORT IN N <sup>+</sup> BEAM INDUCED pi-<br>BONDED NANOCRYSTALLINE CLUSTERS IN POLY PHENYLENE<br>OXIDE  |

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| 10:35 - 11:00   | J. Swiatowska-Mrowiecka, University of Mining and Metallurgy:<br>INFLUENCE OF THE CRYSTALLOGRAFIC ORIENTATION ON THE MECHANISM OF ZINC DISSOLUTION IN ORGANIC SOLVENTS                 |
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| 11:00 - 11:30   | coffee break   |
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| Session Electron microscopy techniques II, chair: N. Yamamoto   |  |
| 11:30 - 12:15   | K. Yagi, Tokyo Institute of Technology:<br>Surface Imaging with use of an Energy Filter  |
| 12:15 - 12:40   | V.Grillo, Universitaet Erlangen-Nuernberg:<br>COMPOSITIONAL FLUCTUATIONS AND LUMINESCENCE PROPERTIES OF InGaN QUANTUM WELLS GROWN ON GaN AND SAPPHIRE SUBSTRATES: A COMPARISON         |
| 12:40 - 13:05   | M. Starowicz, University of Mining and Metallurgy, Krakow:<br>ELECTROCHEMICAL DEPOSITION OF SI(IV) COMPOUNDS ON THE METAL SURFACE FROM ANHYDROUS ORGANIC SOLVENTS                      |
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| 13:05 - 14:30   | lunch break  |
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| Session Electron microscopy techniques III, chair: T. Sekiguchi |  |
| 14:30 - 15:15   | G. Salviati, MASPEC-CNR Institute Parma:<br>Cathodoluminescence submicrometric depth profiling of optical emissions in semiconducting heterostructures and devices                     |
| 15:15 - 15:40   | O. Martinez, Dpto. Física de la Materia Condensada. E.T.S.I.I. Valladolid:<br>MICROCHARACTERIZATION OF CONFORMAL GaAs AND AlGaAs ON Si LAYERS BY SPATIALLY RESOLVED OPTICAL TECHNIQUES |
| 15:40 - 16:25   | T. Sekiguchi, National Research Institute for Metals Tsukuba:<br>Low-energy Cathodoluminescence Study of Semiconductor Nanostructures and Nanoparticles                                |
| 16:25 - 16:40   | Concluding remarks by the workshop vice-chairman N. Yamamoto   |

**Friday, 15 December 2000**

8:00 - 22:00

Excursion to [CNR-MASPEC](#) in Parma